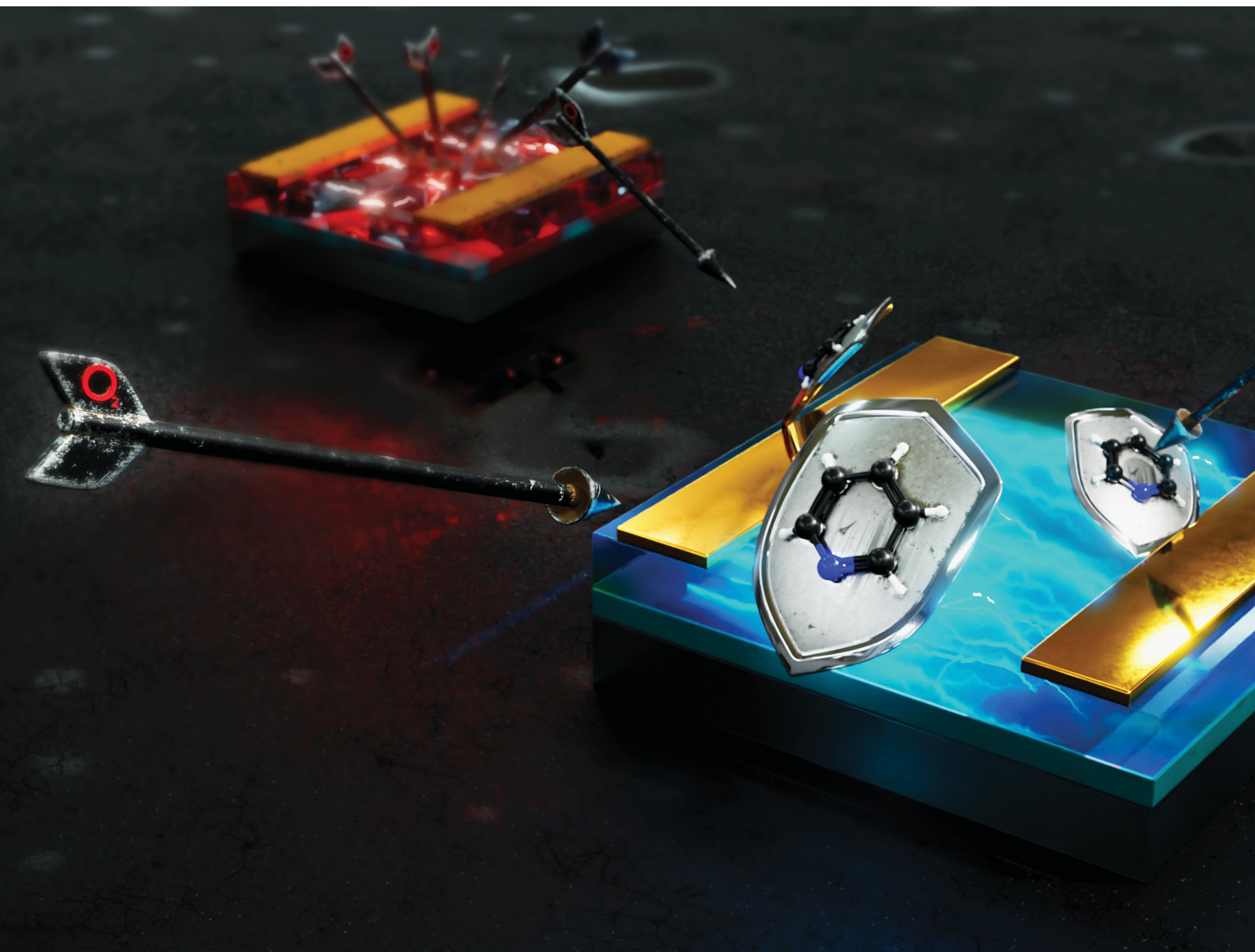


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COMMUNICATION

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Exposure to solvent vapours for enhanced N-type
OTFT stability